PATENT

Attorney Docket No. 008401 05 RW Ref. No. APM/004-03-5

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

The Application of:

Kenneth COLLINS, et al.

Group Art Unit: Unknown

Entitled: PLASMA IMMERSION ION: IMPLANTATION APPARATUS INCLUDING AN: INDUCTIVELY COUPLED PLASMA SOURCE: HAVING LOW DISSOCIATION AND LOW:

MINIMUM PLASMA VOLTAGE

Examiner: Unknown

Serial No.: 10/646,528

Filing Date: August 22, 2003

## PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to taking action in this case, please amend the above-identified patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 4 of this paper.